

PRESS RELEASE 1 June 2022

Obducat receives final acceptance for EITRE® Large Substrate system

OBDUCAT AB's (publ) subsidiary Obducat Technologies AB, a leading supplier of Lithography solutions based on nanoimprint lithography (NIL), confirm that final acceptance has been obtained for the EITRE Large Substrate system delivered in 2020 to a customer in Asia.

Obducat has now completed the installation of and conducted tests for the final acceptance of the EITRE Large Substrate system which was delivered to a customer in Asia in 2020. Installation has primarily been delayed as a result of restrictions related to the Corona pandemic.

The customer has put the system into operation immediately after the final acceptance. Further information about the customer and the applications in which the EITRE system will be used cannot be disclosed due to confidentiality requirements from the customer.

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About Obducat AB (publ)

Obducat AB (publ) is an innovative developer and supplier of technologies, products and processes used for the production and replication of advanced micro and nano structures. Obducat's products and services serve the demands of companies within the LED, OLED, semiconductor, displays, biomedical and MEMS industries. Obducat's technologies include nano imprint technology, coating technology and wet processing technology. Obducat has offices in Sweden, Germany and China and the headquarter is located in Lund, Sweden. Obducat is a public company. Obducat's shares are traded on the Swedish NGM Main Regulated Equity exchange. Read more at www.obducat.com.